

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 09/030,618  
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 Inventor ..... Richard Holscher et al.  
 Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 1756  
Priority Examiner ..... K. Duda  
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 Title: Semiconductor Processing Methods

**PRELIMINARY AMENDMENT**

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

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**AMENDMENTS****In the Specification**

At page 1, before the "Technical Field" section, insert the following paragraph in accordance with 37 C.F.R. § 1.121(b)(1)(ii):

**RELATED PATENT DATA**

This patent resulted from a continuation application of U.S. Patent Application Serial No. 09/030,618, filed February 25, 1998.